



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hisaji OYAKE et al.

Group Art Unit: 2854

Application No.: 10/500,816

Examiner: A. NGUYEN

Filed: July 7, 2004

Docket No.: 120321

For: METHOD OF MANUFACTURING STAMPER FOR MANUFACTURING INFORMATION MEDIUM, STAMPER, AND PHOTORESIST MASTER

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 2, 2006, Office Action, the period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.